

In the Specification:

As requested in the amendment filed January 6, 2005, please substitute the following Title of the application for the Title as originally filed at all occurrences in the application:

ELECTROSTATIC DISCHARGE SEMICONDUCTOR PROTECTION
CIRCUIT OF REDUCED AREA

Additionally, please substitute the following paragraph for the corresponding paragraph beginning at Page 7, line 2 in the specification as originally filed.

Preferably, the semiconductor device further ~~comprising~~ comprises a second diffused region (45) connected to the diffused region (44) so that the PN junction (D1) is formed with the ~~defused~~ diffused region (44).